Docket No. 0080903

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re App	olication of:)
Serial No	Rahul Surana, et al. 10/809,906	Examiner: McDonald, Shantese L. Art Unit: 3723
Filed:	March 26, 2004	
S	A Technique For Process-Qualifying A Semiconductor Manufacturing Tool Using Metrology Data) _) _)
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AMENDMENT AND RESPONSE TO OFFICE ACTION

Sir:

In response to the Final Office Action mailed October 6, 2006, Applicants respectfully request the Examiner to enter the following amendments and consider the following remarks:

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

on <u>April 5, 2007</u>			
Date of Deposit			
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Michelle Boa	April 5, 2007		
Signature	Date		